Decto N. 60188-431

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e Application

Customer Number: 20277

Akihika 4012 BASHI, et al.

Confirmation Number: 6491

Serial No.: 10/017,389

Group Art Unit: 2818

Filed: December 18, 2001

Examiner: Mai Huong C. Tran

For:

METHOD FOR FABRICATING SEMICONDUCTOR, METHOD FOR FABRICATING

SEMICONDUCTOR SUBSTRATE, AND SEMICONDUCTOR LIGHT EMITTING DEVICE

Mail Stop Non-Fee Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

<u>Transmitted</u> herewith is an Amendment in the above-identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached:

Supplemental Information Disclosure Statement and PTO 1449

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	17	20	0	\$18.00 =	\$0.00
Independent Claims	7	7	0	\$84.00 =	\$0.00
		Multiple claims ne	Multiple claims newly presented		
		Fee for extension of time			\$0.00
					\$0.00
			Total of Above Calculations		\$0.00

Please charge my Deposit Account No. <u>500417</u> in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

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